



OK TO ENTER: /R.S.W./

AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit: 1711

Serial No.: **10/576,277**

Examiner: **WALTER JR, Robert S.**

Filed: **April 18, 2006**

P.T.O. Confirmation No.: 9712

For: **METHOD OF FORMING LUSTER COATING FILM**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1711

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 27, 2010

Sir:

In response to the Office Action dated April 28, 2010, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.